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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial	No 10/741,300
	December 17, 2003
	Trung Tri Doan et al
Assignee	Micron Technology, Inc
	2825
	Igwe U. Anya
	Ml22-2471
	Atomic Layer Deposition Apparatus and Method

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

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- 2. Transmittal Form
- 3. Statement of the Substance of the Interview

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Under the Paperwork N	educifor Act of 1889. No se	Application Number	10/741,30		
TRANSMITTAL		Filing Date	December	r 17, 2003	
FO	RM	First Named Inventor	Trung Tri I	Doan	
		Art Unit	2825		
(to be used for all correspondence after initial filing)		Examiner Name	Igwa U. Aı	Igwe U. Anya	
Total Number of Pages in This Submission		Attorney Docket Number	Mi22-2471		
	E	NCLOSURES (Check a	I that apply	y)	
Fee Transmittal Fo		Drawing(s)		After Allowance Communication to TC	
Fee Attach		Licensing-related Papers		Appeal Communication to Board of Appeals and Interferences	
Extension of Time Express Abandoni Information Disclor Certified Copy of F Document(s) Reply to Missing F Incomplete Applica Reply to M	Request ment Request sure Statement Priority Parts/	Petition Petition to Convert to a Provisional Application Power of Attorney, Revocati Change of Correspondence Terminal Disclaimer Request for Refund CD, Number of CD(s) Landscape Table on Comarks tomer No. 021567. FEE REQUIRED. ere is a fee, charge to Deposit A	Address D	Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Other Enclosure(s) (please Identify below): Certificate of Facsimile Transmission; Statement of the Substance of the Interview (of 10/19/04)	
	SIGNATUR	E OF APPLICANT, ATTO	RNEY, O	OR AGENT	
Firm Name Wells	St. John P.S.				
Signature	Deece	men			
Printed name Mark S. Matkin					
Date	10/21	104	Reg. No.	32,268	
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	
	December 17, 2003
•	Trung Tri Doan et al
	Micron Technology, Inc
	2825
Examiner	
Attorney's Docket No	MI22-2471
Customer No	021567
TitleAtomic	Layer Deposition Apparatus and Method

STATEMENT OF THE SUBSTANCE OF THE INTERVIEW

To:

Commissioner for Patents

ATTENTION: Examiner Ugwe U. Anya Group Art Unit 2825

P. O. Box 1450

Alexandria, VA 22313-1450

VIA FACSIMILE

From:

Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)

Wells St. John P.S.

601 West First Avenue, Suite 1300

Spokane, WA 99201-3828

An interview was conducted between the undersigned and Examiner Anya on October 19, 2004.

Claims 1, 18, 54 and 55 were discussed, as were U.S. Patent Nos. 6,461,436 and 6,206,970. Agreement was reached with respect to added claims 54 and 55, and the amendments made to independent claims 1 and 18. With respect to the '436 patent, the undersigned asserted, and did so in his last-filed response, that such is not prior art to this application.

The Examiner indicated that the records available to him did not show that the instant application had been assigned to Micron Technology, and that he would further research the matter. Although the undersigned did not WELLS ST JOHN PS 5098383424 P.04

have the entirety of the 10/741,300 file with him during the interview, the undersigned indicated that he believed such an assignment had indeed

been filed.

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Upon review of the entire file, it is proven that the above-referenced patent application, as a divisional of parent application 10/097,025, is assigned to Micron Technology, Inc. in an assignment recorded on March 11, 2002 in Reel 012709 at Frames 0181-0185.

Respectfully submitted,

Dated: 10-21-04

Mark S. Matkin Reg. No. 32,268